

Search Notes

Application/Control No.

10/532,070

Examiner

Steven D. Maki

Applicant(s)/Patent under
Reexamination

YAMANE, KENJI

Art Unit

1733

SEARCHED

Class	Subclass	Date	Examiner
152	209.15		
	209.18		
	209.24		
	209.26		
	209.27		
	209.28		
updated	above	7/30/2007	<i>JM</i>

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
none	7/30/2007	<i>JM</i>